



Remcom, Inc.

315 South Allen Street
Suite 416
State College, PA 16801

www.remcom.com
sales@remcom.com

Toll free: 1-888-7-REMCOM
Tel: 1-814-861-1299
Fax: 1-814-861-1308

RLD

Rotman Lens Designer

$$\nabla \times \mathbf{E} = -\frac{\partial \mathbf{B}}{\partial t}$$



- * RLD is a special-purpose software tool for designing Rotman Lenses
- * It is based on theoretical equations and Geometrical Optics
- * Calculations are performed in real time with interactive redrawing of the design and output quantities
- * It is intended for microstrip and stripline lenses at frequencies up to 45 GHz
- * It is cross platform compatible for Windows and Linux

$$B = \mu H$$

$$\nabla \cdot B = 0$$

$$\nabla \cdot D = \rho$$

$$D = \epsilon E$$

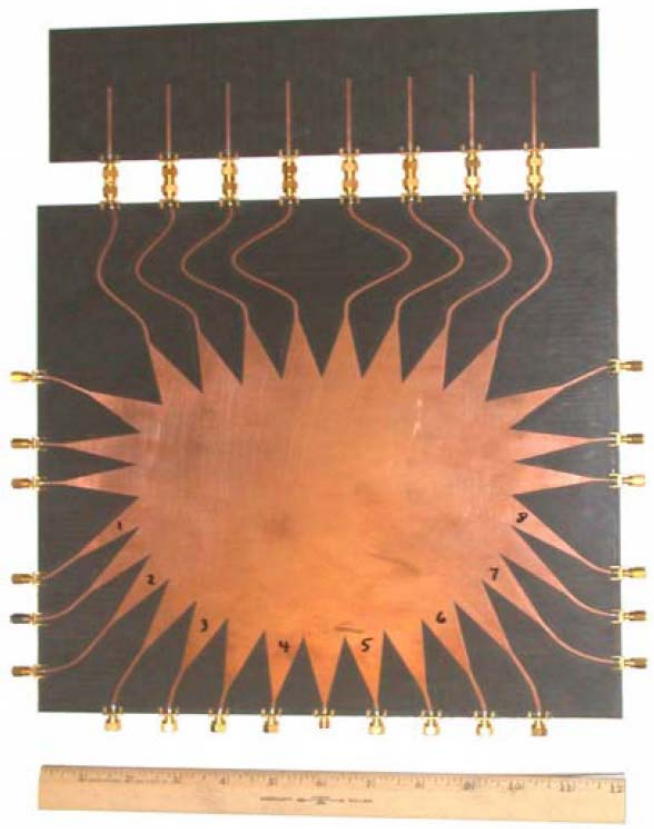
- * RLD grew out of a US Army SBIR from the Army Research Laboratory
- * Army needed a tool for designing low cost, true time delay beamformers
- * Available as a commercial product since 2006
- * Successfully used by both the US Army and academic researchers to design and fabricate Rotman Lenses
- * Measured results of fabricated lenses have shown good agreement with RLD calculations (see references)

$$B = \mu H$$

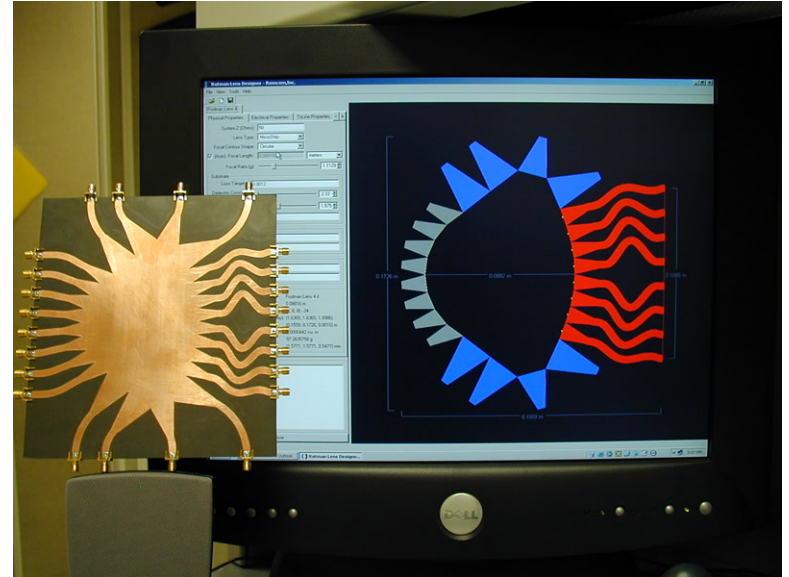
$$\nabla \cdot B = 0$$

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4.6 GHz, 8 beam lens
 Courtesy Dr. Steven Weiss
 US Army Research Laboratory



10 GHz, 8 beam lens shown with RLD design
 Courtesy Dr. Erik Lenzing
 Penn State Applied Research Laboratory

$$B = \mu H$$

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- * Typical lens design parameters are available as inputs to the software
- * The Lens design is interactively redrawn as parameters are adjusted
- * Several performance criteria may be plotted and interactively updated while input parameters are adjusted
- * Feed lines to all ports may be added and routed
- * Lens design may be exported to a full wave solver for further analysis or into a CAD format for fabrication

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Rotman Lens Designer - Remcom, Inc.

File View Tools Help

Ku Band Lens

Physical Properties | Electrical Properties | TxLine Properties

System Z (Ohms): 50

Lens Type: MicroStrip

Focal Contour Shape: Circular

(Auto) Focal Length: 0.236 meters

Focal Ratio (g): 1.0999

Substrate

Loss Tangent: 0.0005

Dielectric Constant: 2.33

Thickness (mm): 0.508

Density (g/cm³): 2.1

Metalization

Conductivity (S/m): 5.0e+07

Thickness (mm): 0.1

Absorber

Dielectric Constant: 2.5

Conductivity (S/m): 1

0.2360 m

0.3909 m

0.1960 m

- Beam to Array Phase Error for Ku Band Lens

Beam to Array Phase Error

Phase (deg.)

0.600

0.500

0.400

0.300

0.200

0.100

12.5 17.5 22.5

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- * Inputs are divided into categories of physical properties and electrical properties
- * Separate tabs list the available parameters
- * Most inputs are controlled by both text screens and slider bars
- * Lens design is redrawn as the parameters are changed

$$B = \mu H$$

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- * Physical properties are quantities such as the system impedance, the focal length and the focal ratio
- * Values for the substrate, metallization layer, and any absorber dielectric are included
- * A summary screen lists details about the design

Physical Properties	Electrical Properties	TxLine Properties
System Z (Ohms):	50	
Lens Type:	MicroStrip	
Focal Contour Shape:	Circular	
<input checked="" type="checkbox"/> (Auto) Focal Length:	18.4911	wavelengths
Focal Ratio (g):	1.1370	
Substrate		
Loss Tangent:	0.0005	
Dielectric Constant:	2.50	
Thickness (mm):	1.524	
Density (g/cm ³):	2.1	
Metalization		
Conductivity (S/m):	5.8e+07	
Thickness (mm):	0.1	
Absorber		
Dielectric Constant:	2.5	
Conductivity (S/m):	1	
Lens Info		
Loaded from:	"new lens"	
Focal Length:	18.49110 wavelengths	
Ports (beam, array, dummy) - total:	(16, 32, 0) - 48	
Approx. VSWR (beam, array, dummy):	(1.6365, 1.6365, 1.6365)	
Dimensions (width, height, depth):	(0.4688, 0.5318, 0.0017) m	
Volume:	0.0004299 cu. m	
Weight:	902.7288188 g	
Approx. FDTD cell size (x,y,z):	(1.4535, 1.4535, 0.5747) mm	

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- * Electrical properties include the center frequency, bandwidth, element spacing, and scan angle
- * Details about the Beam and Array contours are set
- * Control of the sidewall absorption through material or dummies

Physical Properties	Electrical Properties	TxLine Properties
Center Frequency (MHz): <input type="text" value="9600"/>		
Bandwidth (MHz): <input type="text" value="1600"/>		
Element Spacing: <input type="text" value="0.46431"/> wavelengths		
Beam Port Excitation: Uniform View		
Aperture Distribution: Manual		
Max Scan Angle (degrees): <input type="text" value="50.00"/>		
Alpha Ratio: <input type="text" value="0.800"/>		
Beam Contour		
Number of Beams: <input type="text" value="16"/>		
Max Port Size (wavelengths): <input type="text" value="2.00"/>		
Flare Angle (Degrees): <input type="text" value="12.00"/>		
<input type="checkbox"/> Enable port pointing		
Array Contour		
Number of Elements: <input type="text" value="32"/>		
Max Port Size (wavelengths): <input type="text" value="2.00"/>		
Flare Angle (Degrees): <input type="text" value="12.00"/>		
<input type="checkbox"/> Enable port pointing		
Sidewalls		
<input checked="" type="checkbox"/> Absorber Sidewalls		
Contour Curvature: <input type="text" value="0.75"/>		
Max Port Size (wavelengths): <input type="text" value="2.00"/>		
Flare Angle (Degrees): <input type="text" value="12.00"/>		
Absorber Width Factor: <input type="text" value="0.010"/>		

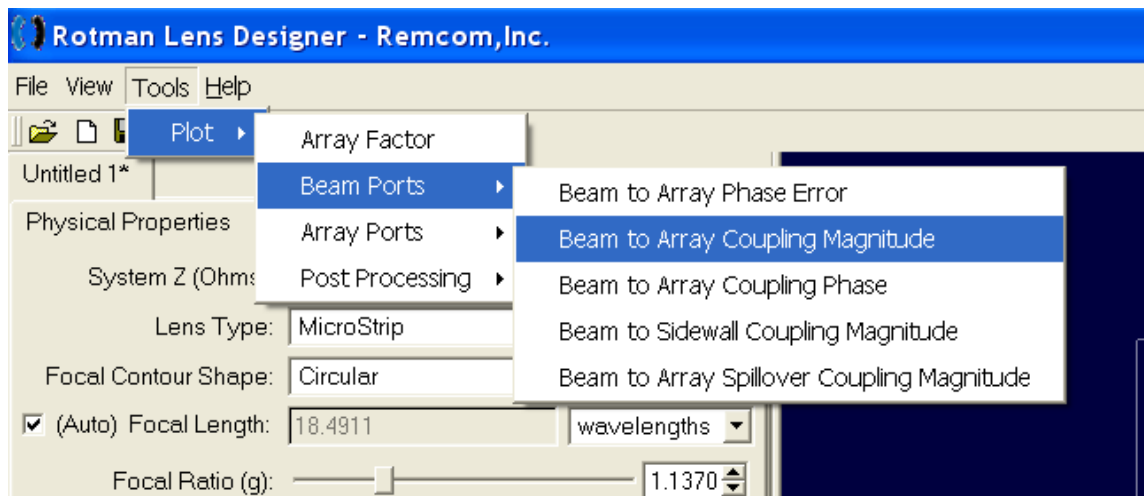
$$B = \mu H$$

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- * A number of lens performance criteria may be plotted as the design is tuned
- * Array factor displays the beam pattern produced at the output elements of the lens
- * Beam and Array Coupling and phase error may be plotted



$$B = \mu H$$

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- * After a lens design is tuned several output values may be computed
- * S-parameters and insertion loss are available for every port
- * The lens design may be exported in several formats for further analysis or fabrication
- * Original intended use of the software was for export of the design to a full wave solver for fine tuning
- * Actual use has shown the RLD results are often sufficiently accurate

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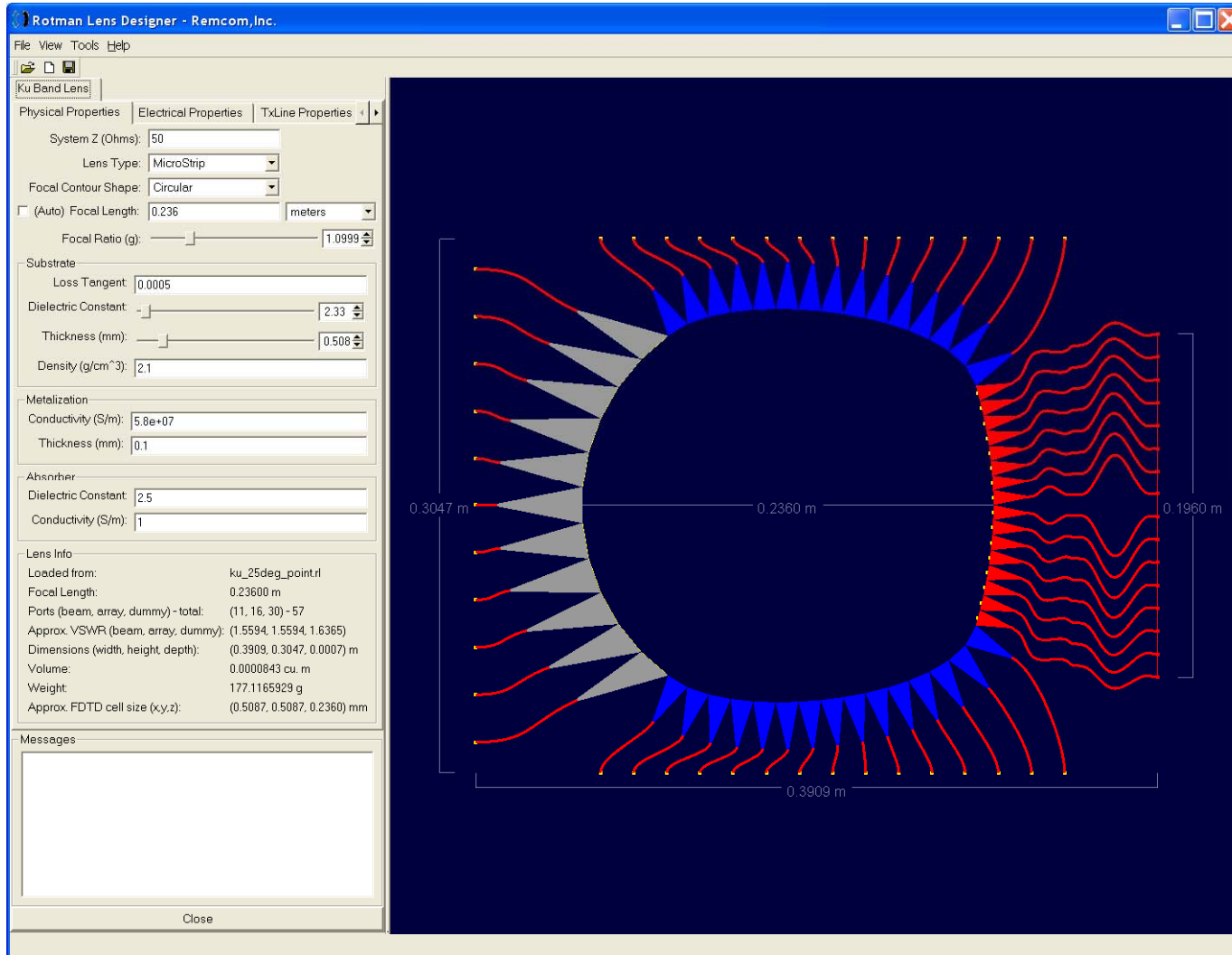
- * A microstrip lens with a center frequency of 16 GHz will be designed and compared to results from a full wave solver (XFDTD)
- * The lens will produce 11 beams for a 16 element linear array with a scan angle of 25 degrees
- * Beam patterns and S-parameter results will be compared to XFDTD

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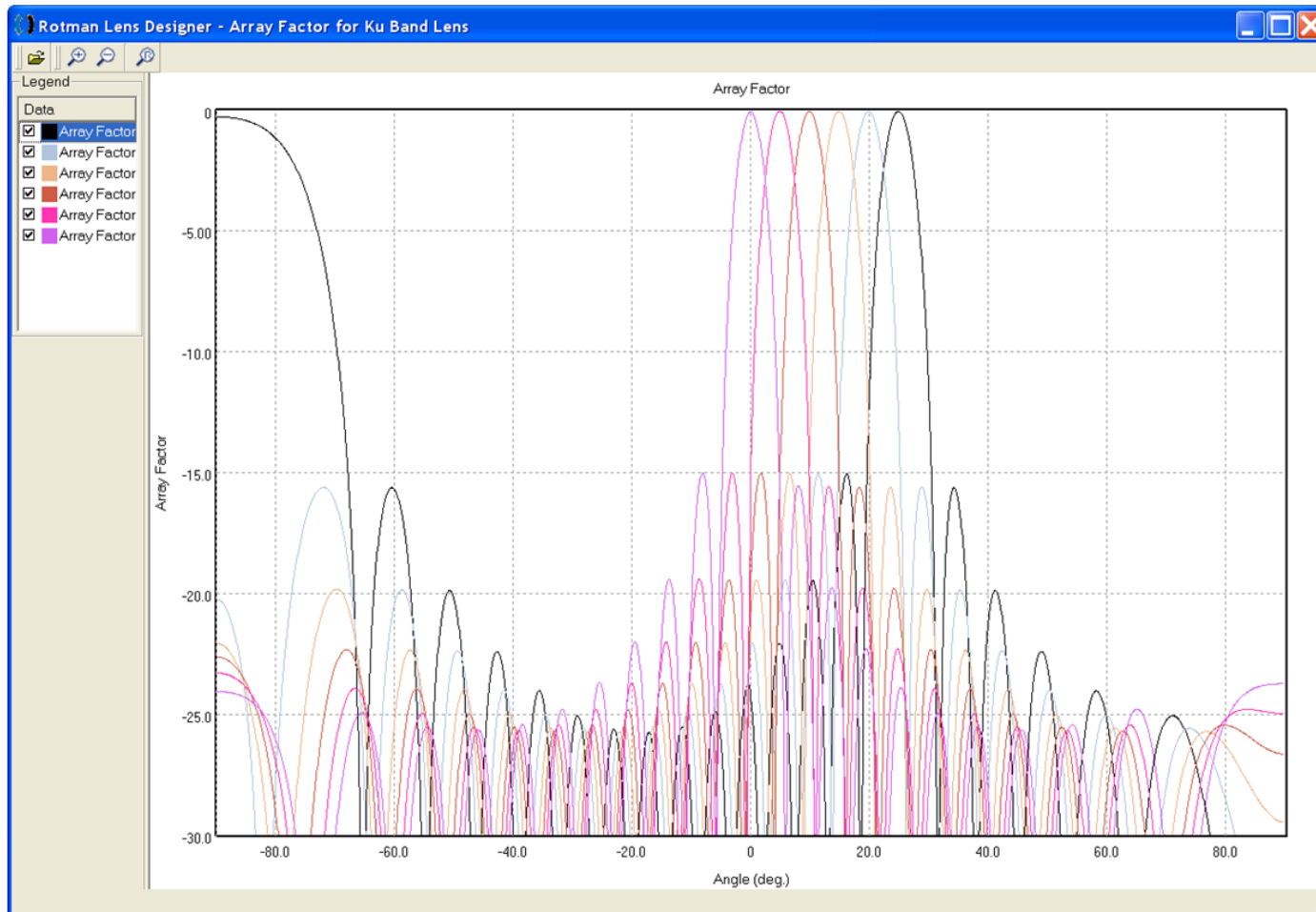
Ku band Lens after tuning

$$B = \mu H$$

$$\nabla \cdot B = 0$$

$$\nabla \cdot D = \rho$$

$$D = \epsilon E$$



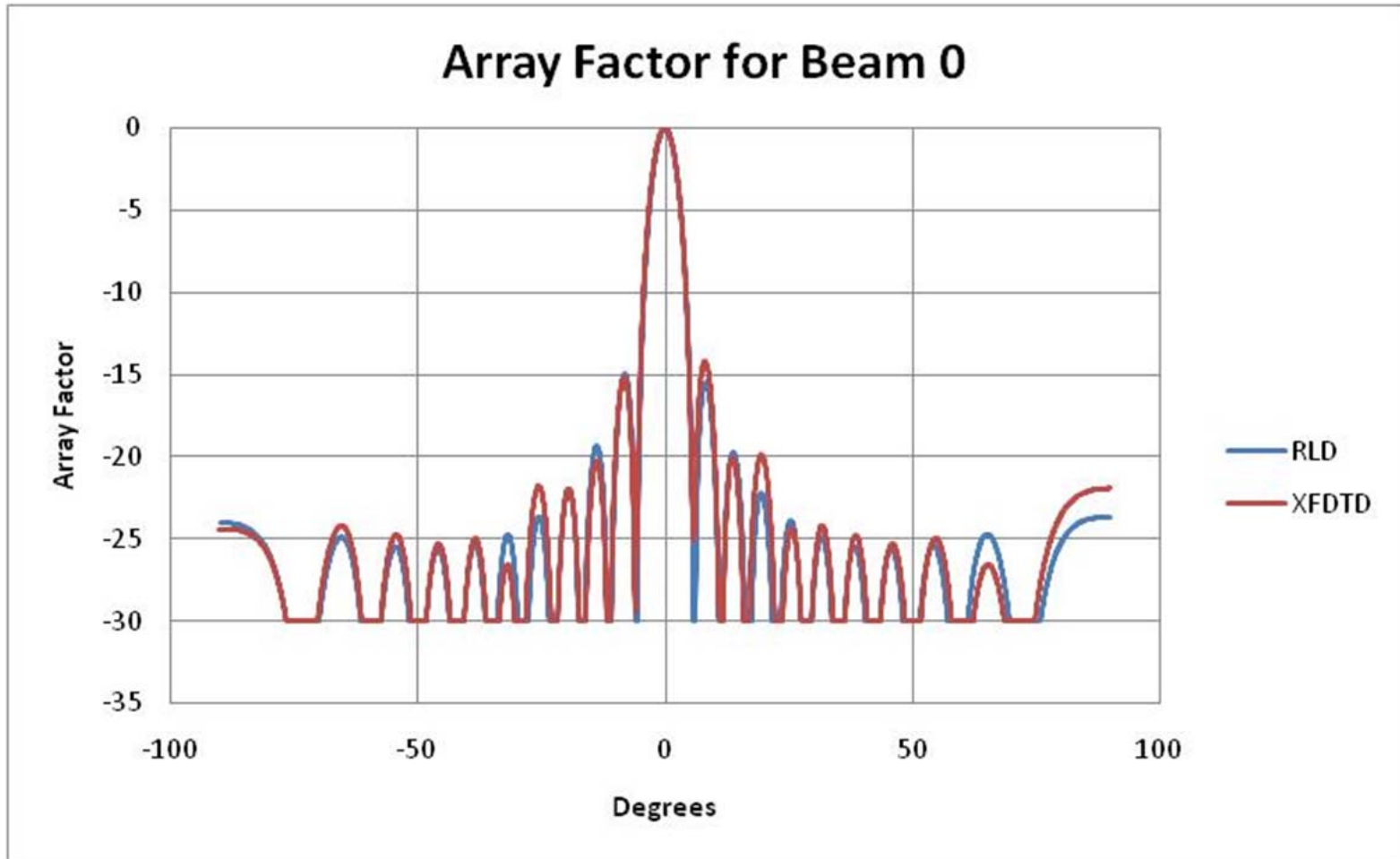
Half of the beams formed by the lens are shown

$$B = \mu H$$

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Good agreement is found for the center beam

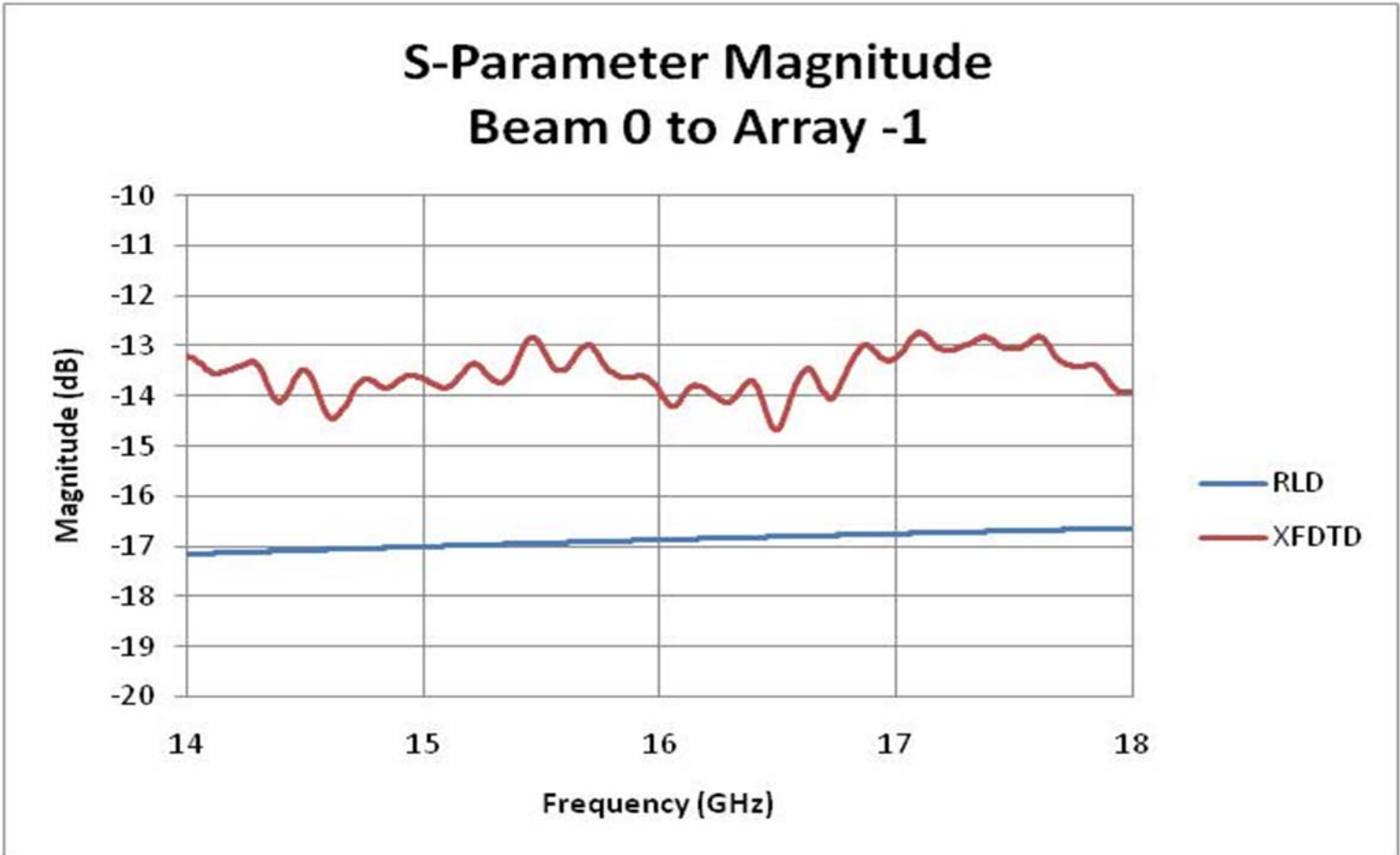
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S-Parameter Magnitude vs. Frequency



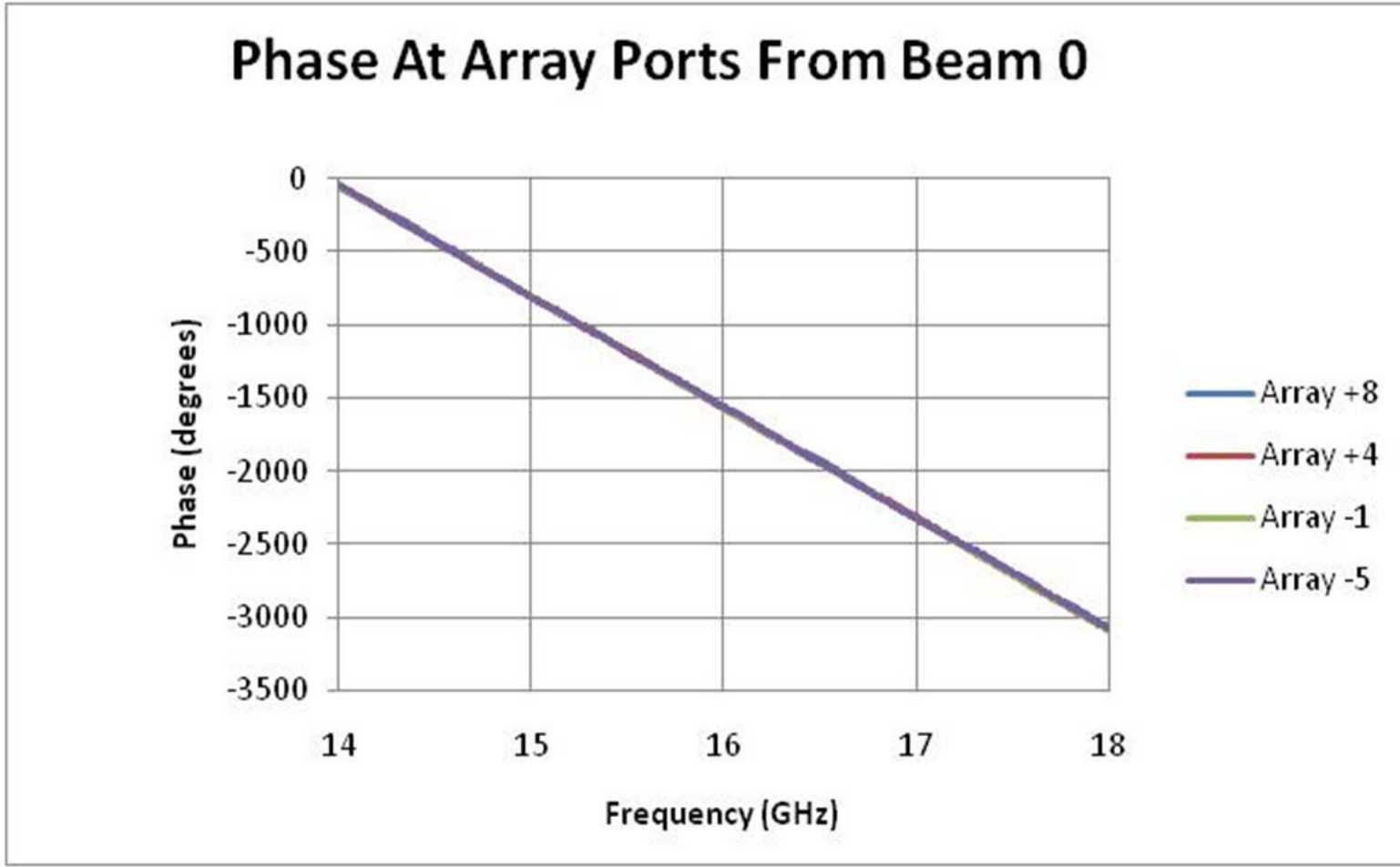
RLD S-parameter computation is conservative compared to full wave result

$$B = \mu H$$

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Phase remains linear as a function of frequency

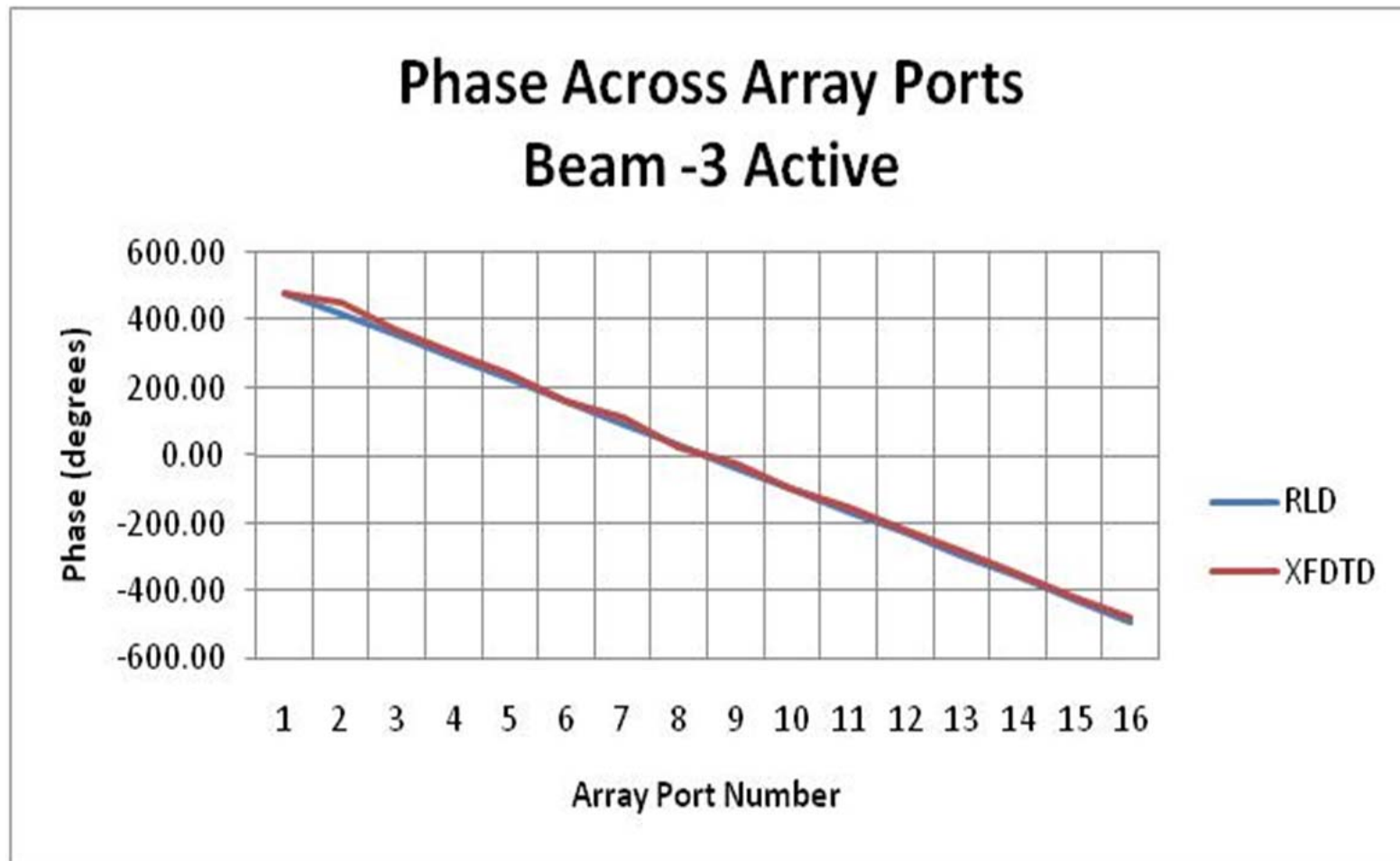
$$B = \mu H$$

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S-Parameter Phase across Output Ports



Phase across output (array) ports is in good agreement with XFDTD

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- * RLD is an easy to use tool for initial design of Rotman Lenses
- * Tuning process is intuitive as output criteria are updated in real time as lens parameters are changed
- * Results have been shown to have good agreement with full wave and measured results

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For further reading on RLD results, including comparisons with measured results, see the following

S. Weiss, S. Keller, and C. Ly, "Development of Simple Affordable Beamformers for Army Platforms," presented at *2007 GOMACTech Conference*, Lake Buena Vista, FL, March 2007.

C. W. Penney, R. J. Luebbers, E. Lenzing, "Broad Band Rotman Lens Simulations in FDTD," in *Proc. 2005 IEEE AP-S International Symposium*, vol. 2B, pp. 51-54, July 2005.

S. Albarano III, E. H. Lenzing, C. W. Penney, and R. J. Luebbers. "Combined Analytical-FDTD Approach to Rotman Lens Design," presented at the *22th Annual Review of Progress in Applied Computational Electromagnetics*, Miami, FL, March 2006.

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